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Docket No. TIP487US

TI-36657

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re **PATENT** application of:

Applicant: David A. Stark et al.

Application No.: 10/696,623

For: CHEMICAL MECHANICAL POLISHING SYSTEM

Filing Date: October 29, 2003

Examiner: Maurina T. Rachuba

Art Unit: 3723

REPLY TO OFFICE ACTION DATED AUGUST 12, 2005

Mail Stop Amendment
Assistant Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Favorable reconsideration of the above-identified application is respectfully requested in view of the following amendments and remarks.

